

# Notice of References Cited

09/555,987

Examiner  
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Applicant(s)/Patent Under  
Reexamination  
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Art Unit  
1617

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## U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification	
	A	US-5,518,751-	05-1996	de Boer et al.	--	--
	B	US- -				
	C	US- -				
	D	US- -				
	E	US- -				
	F	US- -				
	G	US- -				
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## FOREIGN PATENT DOCUMENTS

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## NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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